

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/743,105  
Applicant : Christoph Nolscher  
Confirmation No. : 8012  
Filed : December 23, 2003  
TC/A.U. : 1756  
Examiner : Chacko Davis, Daborah  
Customer No. : **27896**  
Docket No. : 3000.0016C  
Title : Method for Forming a Structure Element on a  
Wafer by Means of a Mask and Trimming Mask  
Assigned Hereto

### ISSUE FEE TRANSMITTAL

IN RESPONSE TO THE NOTICE OF ALLOWANCE MAILED JULY 17, 2007, ENCLOSED ARE

☒ Issue Fee Transmittal (Form PTOL 85b)

☐ Other: \_\_\_\_\_

THE FEES HAVE BEEN CALCULATED AS FOLLOWS:

☒ Issue Fee: \$1440.00

(\$1440 LargeEntity/\$720 SmallEntity)

☒ Publication Fee (\$300): \$300.00

☐ Other Fees: \$\_\_\_\_\_

**Total Fee Due: \$1740.00**

☒ Credit card payment has been submitted concurrently with the filing of this transmittal. The Director is hereby authorized to charge any additional appropriate fees that may be required during the pendency of the above-identified application (e.g., in the concurrent or in any future reply), as well as to credit any overpayment, to Deposit Account No. **05-0460**.

Dated: October 10, 2007

Respectfully submitted by:

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/Andrew J. Aldag/

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